Electronic Acknowledgement Receipt FES ID: 1066876 Application Number: 10801208 Confirmation Number: 2034 Methods of manufacturing semiconductor devices having a ruthenium Title of Invention: layer via automatic layer deposition First Named Inventor: Kwang-hee Lee Customer Number: 20792 Filer: D. Randal Ayers/Michele McMahan Filer Authorized By: D. Randal Ayers Attorney Docket Number: 5649-1277 Receipt Date: 05-JUN-2006 Filing Date: 16-MAR-2004 Time Stamp: 14:08:43 Application Type: Utility International Application Number:

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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt. in due course.